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To:	Examiner E.J. Kielin Group Art Unit: 2813	From:	Leslie S. Szivos, Ph.D.
Fax:	703-872-9306	Pages:	14 including cover
Phone:		Date:	October 26, 2004
Re:	Jack O. Chu, et al. U.S. Patent Appln. No. 09/692,606 Our Docket: 17178	CC:	

☒ XX Urgent ☐ For Review ☐ Please Comment ☐ Please Reply ☐ Please Recycle

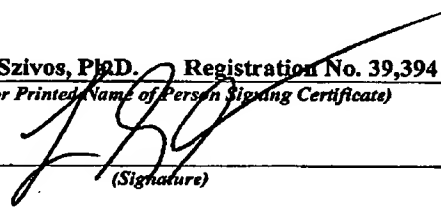
Dear Sir:

The following is attached hereto:


1. Response Under 37 C.F.R. §1.111
2. Amendment Transmittal
3. Authorization to charge deposit acct. no. 50-0510/IBM
4. Certificate of Facsimile

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)			Docket No. YOR920000344US1 (17178)	
Applicant(s): Jack O. Chu, et al.				
Application No. 09/692,606	Filing Date 10/19/2000	Examiner E.J. Kielin	Group Art Unit 2813	
Invention: LAYER TRANSFER OF LOW DEFECT SiGe USING AN ETCH-BACK PROCESS				
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<p>I hereby certify that this _____ Response Under 37 C.F.R. §1.111 _____ (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9306</u>)</p> <p>on <u>October 26, 2004</u> (Date)</p> <p style="text-align: center;"><u>Leslie S. Szivos, Ph.D.</u> <u>Registration No. 39,394</u> (Typed or Printed Name of Person Signing Certificate)</p> <p style="text-align: center;"> (Signature)</p>				
Note: Each paper must have its own certificate of mailing.				

P18/REV02

AMENDMENT TRANSMITTAL LETTER (Large Entity)				Docket No. YOR92000344US1 (17178)	
Applicant(s): Jack O. Chu, et al.					
Application No. 09/692,606	Filing Date 10/19/2000	Examiner E.J. Kielin	Customer No. 23389	Group Art Unit 2813	Confirmation No. 7913
Invention: LAYER TRANSFER OF LOW DEFECT SiGe USING AN ETCH-BACK PROCESS					
<u>COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	40 -	42 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	3 -	3 =	0 x	\$86.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
 <input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 50-0510/IBM <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <div style="display: flex; justify-content: space-between; align-items: flex-end;"><div style="text-align: center;"> _____ <i>Signature</i> Leslie S. Szivos, Ph.D. Registration No. 39,394 Customer Number: 23389</div><div style="text-align: right;">Dated: October 26, 2004</div></div>					
<div style="border: 1px solid black; padding: 5px; width: fit-content;"><p>I certify that this document and fee is being deposited on with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.</p><hr/><p style="text-align: center;"><i>Signature of Person Mailing Correspondence</i></p><hr/><p style="text-align: center;"><i>Typed or Printed Name of Person Mailing Correspondence</i></p></div>					
CC:					

P11LARGE/REV07

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**Applicant(s):** Jack O. Chu, et al.**Examiner:** E.J. Kielin**Serial No.:** 09/692,606**Art Unit:** 2813**Filed:** October 19, 2000**Docket:** YOR920000344US1 (17178)**For:** LAYER TRANSFER OF LOW DEFECT
SiGe USING AN ETCH-BACK PROCESS**Dated:** October 26, 2004**Confirmation No.** 7913Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**RESPONSE UNDER 37 C.F.R. § 1.111**

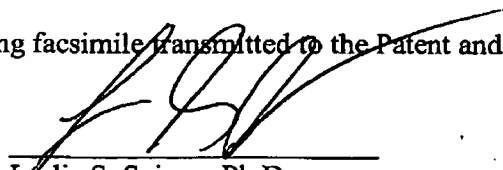
Sir:

In response to the Office Action dated July 26, 2004, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: October 26, 2004



Leslie S. Szivos, Ph.D.